

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wachtmann

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Serial No.: 10/670,673

Art Unit: 2814

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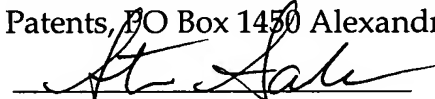
Date: November 3, 2005

Invention: METHOD OF FORMING A
SURFACE MICROMACHINED
MEMS DEVICE

Examiner: Pizarro Crespo, Marcos D

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450 Alexandria, VA 22313-1450 on November 3, 2005.


Steven G. Saunders

PRELIMINARY AMENDMENT

Sir:

In response to the office action dated August 9, 2005, please amend the above-identified patent application as follows:

A listing of claims begins on page 2 of this paper.

Remarks begin on page 6 of this paper.